



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov

| APPLICATION NO. | FILING DATE | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO. | CONFIRMATION NO. |
|-----------------|-------------|----------------------|---------------------|------------------|
| 10/727,692 | 12/04/2003 | Jingkuang Chen | D/A1591D | 8664 |

7590 10/17/2006

OLIFF & BERRIDGE, PLC
P.O. BOX 19928
ALEXANDRIA, VA 22320

EXAMINER

SCHILLINGER, LAURA M

| ART UNIT | PAPER NUMBER |
|----------|--------------|
|----------|--------------|

2813

DATE MAILED: 10/17/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary

Application No.

10/727,692

Applicant(s)

CHEN ET AL.

Examiner

Laura M. Schillinger

Art Unit

2813

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 10 July 2006.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1-14 and 17-22 is/are pending in the application.
- 4a) Of the above claim(s) 3, 21 and 22 is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☐ Claim(s) 1, 4-14, 19-20 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some * c) ☐ None of:
- ☐ Certified copies of the priority documents have been received.
 - ☐ Certified copies of the priority documents have been received in Application No. _____.
 - ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- 1) ☒ Notice of References Cited (PTO-892)
- 2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
- 3) ☐ Information Disclosure Statement(s) (PTO/SB/08)
Paper No(s)/Mail Date _____.
- 4) ☐ Interview Summary (PTO-413)
Paper No(s)/Mail Date: _____.
- 5) ☐ Notice of Informal Patent Application
- 6) ☐ Other: _____.

DETAILED ACTION

Election/Restrictions

Claims 21-22 and 3 are withdrawn from further consideration pursuant to 37 CFR 1.142(b), as being drawn to a nonelected claims, there being no allowable generic or linking claim. Applicant timely traversed the restriction (election) requirement in the reply filed on 7/10/06. It was further determined that claim 3 should also be withdrawn as pertaining to the species requiring a microelectromechanical system element.

Applicant's election with traverse of claims 1,4-14,17-20 in the reply filed on 7/10/06 is acknowledged. The traversal is on the ground(s) that the search could be made without serious burden. This is not found persuasive because the mutually exclusive characteristics of the separate species do constitute a burden.

The requirement is still deemed proper and is therefore made FINAL.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1, 4-14, 17-20 are rejected under 35 U.S.C. 102(b) as being anticipated by Nakagawa et al ('065).

Nakagawa teaches the following claimed limitations:

1. (Previously Presented) The device of claim 13, further comprising: a high voltage well of a first circuit device defined in the substrate (305); and a first low voltage well of a second circuit device defined in the substrate (303) (Fig.28).

4. The device of claim 1, wherein the substrate comprises a layer of silicon (Col.8, lines: 50-60).

5. (Original) The device of claim 4, wherein the layer of silicon comprises p- type silicon (Col.8, lines: 50-60).

6. (Original) The device of claim 1, wherein the substrate comprises a silicon- on-insulator wafer comprising a single-crystal-silicon layer, a substrate and an insulator layer therebetween (Col.7, lines: 35-60).

7. (Original) The device of claim 6, wherein the single-crystal-silicon layer comprises p-type silicon (Col.8, lines: 50-60).

8. (Original) The device of claim 1, further comprising a second low voltage well of the second circuit device defined in the substrate (Fig.34 (305))

Art Unit: 2813

9. (Original) The device of claim 8, further comprising a field oxide layer over at least part of each of the high voltage well, the first low voltage well and the second low voltage well (Fig.34 (325)).

10. (Original) The device of claim 9, further comprising a polysilicon gate associated with each of the high voltage well, the first low voltage well and the second low voltage well (Fig.37D (351)).

11. (Original) The device of claim 10, further comprising:

a P-body defined in the high voltage well of the first circuit device (305);

an N+ source/drain defined in each of the P-body, the high voltage well and the first low voltage well of the second circuit device (307); and

a P+ source/drain in each of the P-body and the second low voltage well of the second circuit device (324) (Fig.34) and Col.15, lines: 50-65).

12. (Original) The device of claim 11, further comprising:

a passivation oxide layer over at least the field oxide layer and the polysilicon gates (Fig.37D (352));

a plurality of vias through the passivation oxide layer; and a plurality of contacts, each of the contacts extending through the vias and contacting at least one of the sources/drains (inherent-need contact holes to form source/drain contacts) (Co.15, lines: 50-65).

13. (Previously Presented) A heterogeneous device, comprising:

a substrate (Fig.13A (51));

a plurality of heterogeneous circuit devices defined in the same substrate (Fig.13A (LED and PD)); and

a photodiode defined in the same substrate (Fig.13A (PD)).

14. The device of claim 13, wherein the plurality of heterogeneous circuits comprises a CMOS and a DMOS (Fig.12D) and Col.8, lines: 30-40 and Col.15, lines: 60-65).

17. (Original) The device of claim 13, wherein the substrate comprises a layer of silicon (Fig.13A (51)).

18. (Original) The device of claim 17, wherein the layer of silicon comprises p-type silicon (Fig.13A (51) and Col.8, lines: 50-60).

19. (Original) The device of claim 13, wherein the substrate comprises a silicon- on-insulator wafer comprising a single-crystal-silicon layer, a substrate and an insulator layer therebetween (Col.7 lines: 35-60).

20. (Original) The device of claim 19, wherein the single-crystal-silicon layer comprises p-type silicon (Col.8, lines: 50-60).

Art Unit: 2813

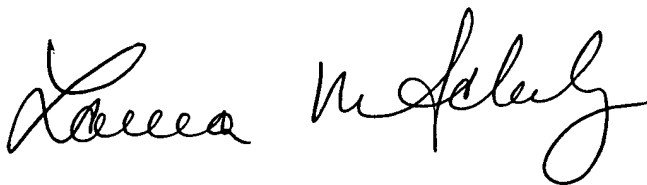
Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Laura M. Schillinger whose telephone number is (571) 272-1697.

The examiner can normally be reached on M-T, R-F 7:00-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl W. Whitehead, Jr. can be reached on (571) 272-1702. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.



Laura M Schillinger
Primary Examiner
Art Unit 2813

10/12/06